CMP Outsource Solutions: Fueling Customer Success

July 2009







Outline



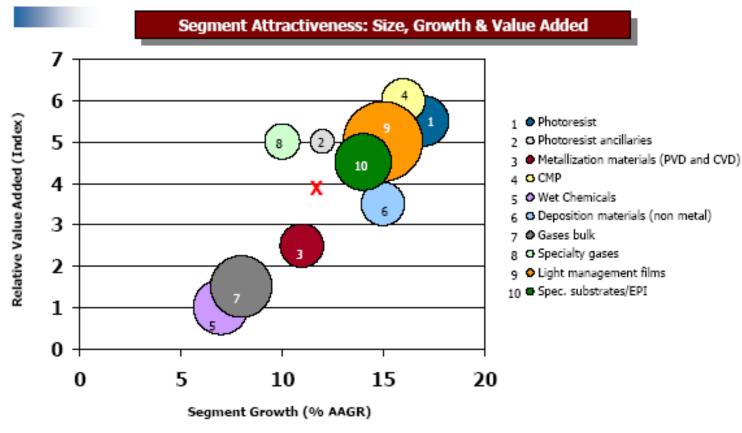
- CMP Evolution
- Development Approach STORM
- Applications and Examples
- History of Partnership
- Market Opportunities
- Services
- Conclusion





CMP Critical to IDM Value Chain







Note: Bubble size proportional to market size (\$M) X indicates portfolio weighted average.

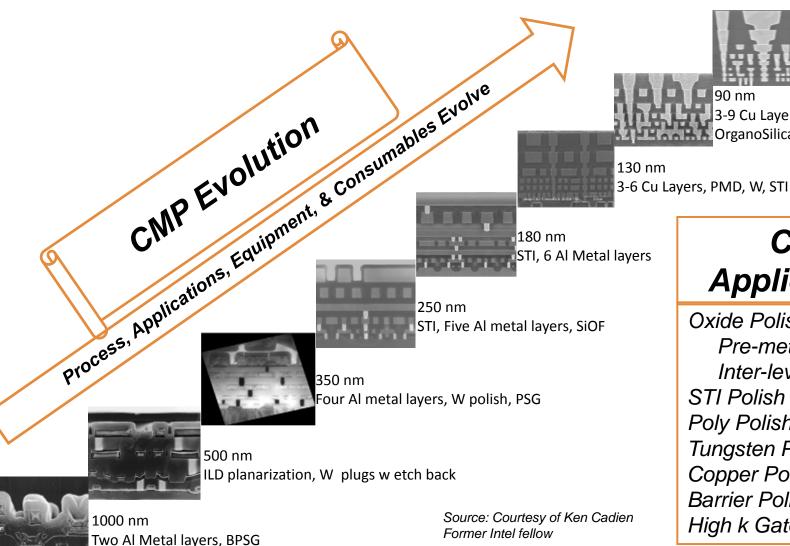




Interconnect **Technology**



90 nm



CMP Applications

3-9 Cu Layers, PMD, W, STI OrganoSilicate Glass (OSG)

65 nm

4-11 Cu Layers

PMD, W, STI, OSG

Oxide Polish Pre-metal Dielectric Inter-level Dielectric STI Polish Poly Polish Tungsten Polish Copper Polish Barrier Polish High k Gate

CMP's Complexity Continues to Evolve



1995 - Qty≤2	2001 - Qty≤ 5
CMOS	CMOS
Glass (oxide)	Glass (oxide)
Tungsten	Tungsten
	Copper
	Shallow Trench
i i	Polysilicon
1	

2009 - Qty ≥ 36		
CMOS	New Apps	Substrate/Epi
Glass (oxide)	Doped Oxides	GaAs
Tungsten	Nitrides	GaN
Copper	NiFe & NiFeCo	InP
Shallow Trench	Noble Metals	CdTe & HgCdTe
Polysilicon	Al & Stainless	Ge and SiGe
Low k	Polymers	SiC
Cap Ultra Low k	Ultra Thin Wafers	Diamond & DLC
Metal Gates	Direct Wafer Bond	Si & Reclaim
Gate Insulators	Through Si Vias	SOI
High k Dielectrics	3-D Packaging	Quartz
Ir & Pt Electrodes	MEMS	Titanium
Magnetics	Nanodevices	
	Integrated Optics	entrepix Your CMP PARTNER



CMP Requires Dedicated Expertise ⇒





vs. Cap-Ex + Op-Ex + Tech Risk...





Why Outsource CMP?



Growing need

- Industry and economic dynamics are accelerating outsourced services
 - Increasing Costs of R&D
 - Preserve capital
 - Headcount reductions reduce resource bandwidth
- Increased need for ability to rapidly & cost-effectively commercialize technologies

Response & Benefits

- Best in class CMP technical staff to support technology development
- Independent 3rd party data generation for IDM evaluations
- Faster time to market for new products
- Flexibility to experiment with new materials and products
- IP Secure environment

Proven model

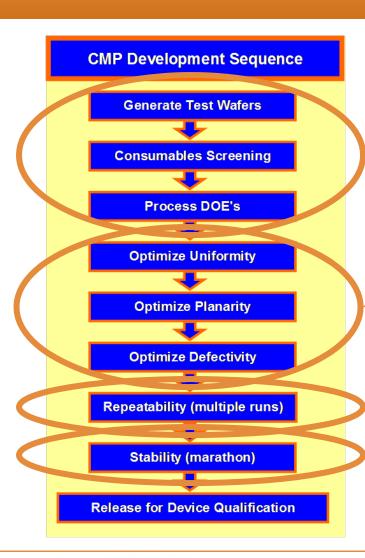
550+ CMP foundry customers globally, across virtually all semiconductor technologies





CMP Development: Proven Approach





- Project each Screening Tests iteria for
- Test wafer availability and quality often impact timeline, validity of results, etc.
- Initial process DOE's generally focus on remove Optimization surface quality
- Optimization stages can be interchanged or executed in parallel
- Plana, Repeatability neight, dishing, erusion, roughness, etc. depending on the material and intended application

Marathon

Failure at any stage usually means backing up at least one stage to try again





CMOS Customer Example



- Project launched to develop a planarized integration for an existing facility running mostly 0.5um and larger devices which did not require CMP.
- Integration included 2 levels of oxide CMP (PMD and ILD) and 2 levels of tungsten CMP (contact and via1).
- Initial estimate was roughly 24 months to purchase, install, and qualify CMP equipment plus develop the integration and be ready for production ramp.
- By leveraging an outsource CMP provider, integration work was started almost immediately and executed in parallel with the equipment lead time.





CMOS Example: Timeline Comparison

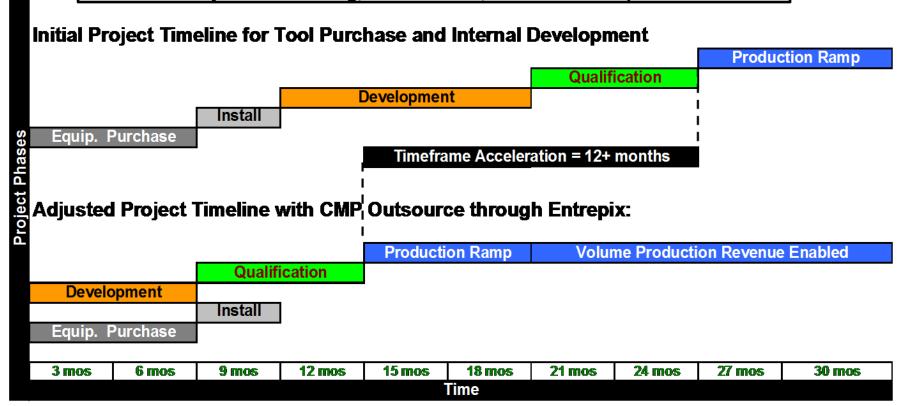


Key aspects of predicted time savings:

Development could begin as soon as test wafers were ready.

Equipment purchase, lead time, and installation in parallel.

Faster cycles of learning, fewer wafers, lower cost compared to internal.

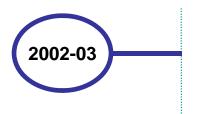




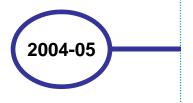


CMP Outsource History

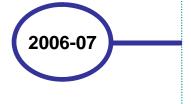




- Entrepix launches CMP Outsource Services
 - Engineering & Technology Development (ETD)
 - Characterize, optimize, materials, process & integration
- SVTC becomes subsidiary of Cypress



- ISO9001:2000 certification
- Multiple IDM qualify and ramp production outsource



- SVTC and ETPX initiate collaboration on 200mm services
- SVTC acquired by OakHill & Tallwood as independent R&D Services Co.
 - Novel materials
 - Analytical services



- SVTC and ETPX partner on 300mm services
- SVTC acquires ATDF R&D Services Co. from SEMATECH
 - Combined strength of both organizations
 - Increase value add to customers





SVTC & Entrepix Partnership



Background

SVTC will outsource to Entrepix all 300 mm chemical mechanical polishing (CMP) development and production services for customers who use the Tool Access Program (TAP) at the SVTC fab in Austin, Texas. Services include:

- Experimental planning and support
- Full engineering project oversight and execution
- Data analysis, interpretation, and reporting
- Pilot production activities

Partnership provides CMP consumable suppliers and device makers with a cost effective solution to drive process optimization and technology advancement.





Combination of Strengths





- ___ State of the art manufacturing facility with 300mm CMP tools
- Global supplier of test wafers to materials and device manufactures
- 24x7 operations & maintenance support
- Access to diverse materials and processes
- Leading edge Analytical Services



- CMP Fast forward™ provides largest portfolio of CMP processes and materials knowledge
- World class engineering and operations experience
- Comprehensive equipment and processing service portfolio
- Flexible, long term customized solutions to meet customer needs

Customers save on capital costs and time by using state-of-the-art CMP tools and processes for development efforts.





Continued Shift Towards Outsourcing

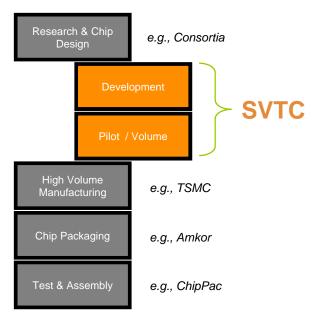


Decade long shift from Vertical to Horizontal Integration accelerating in today's economic condition

Vertical Structure - Past



Horizontal Structure – Future







New Market Opportunities



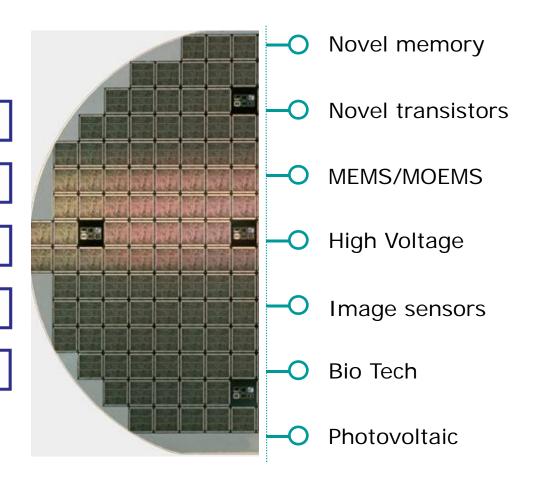
Start-ups

Fabless

IDMs

Foundries

Equipment & Materials





CMP Tool Access Program with Entrepix



Tool Access supports the development efforts of the CMP equipment and material suppliers.

Customer Benefits

- → IP protected access to 200mm and 300mm CMP tools
- All resources in one location; engineering, wafers, metrology, consumables, failure analysis, electrical test
- Baseline ready for your comparison
- Process your customers' wafers for comparison
- Customers save on capital costs by using our state-of-the-art processing tools and engineering support for development efforts.





Tool Access Program





Engineering



Process Characterization



Metrology



Applied Materials Reflexion



Test Wafers



Advanced Test Reticles





CMP Tool Access to Qualify

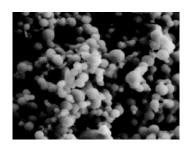




PADS



SLURRIES



ABRASIVES



CONDITIONING DISCS



BRUSHES & CLEAN CHEMISTRIES

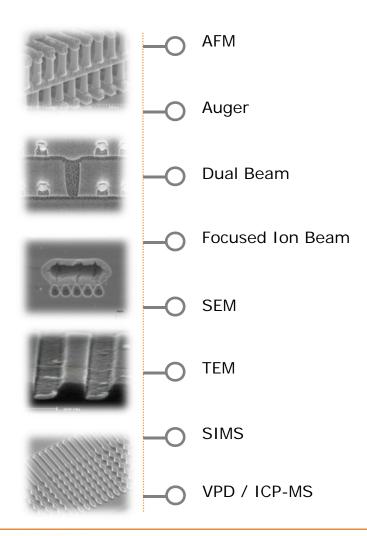


COMPONENTS



Analytical Services





Powerful, in-house suite of leading-edge Analytical Services

On-site wafer and package level Sample Prep Services

Fast turn around times at competitive prices





Conclusions



- Growth of CMP will continue
- Efficient research and development is needed to keep up with the short product life cycles
- CMP process development involves a sequence of stages (STORM) to efficiently reach milestones
- Partnerships will continue to provide more value add to customers
- Proper utilization of CMP outsourcing enables
 - Accelerate timelines
 - Preserve capital
 - Reduce cost and risk



SEMICON Booths



SVTC Booth #5447 North Hall

Entrepix Booth #2227 South Hall

